SEP 2 6 2005

PATENT

Alty. Dkt. No., APPM/005538/PPC/CMP/CKIM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9999

§

തതതതത

In re Application of:

Sun, et al.

Serial No.: 09/755,717

Confirmation No.: 5164

Filed:

January 5, 2001

For:

Tantalum Removal During

Chemical

Mechanical

Polishing

Group Art Unit: 1765

Examiner.

Lan Vinh

L^V 10/7/05

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir.

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (571) 273-6300 to the attention of the named Examiner, on the date below.

9/26/05

Signature

RESPONSE TO FINAL OFFICE ACTION DATED JULY 25, 2005

In response to the Final Office Action dated July 25, 2005, having a shortened statutory period for response set to expire on October 25, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005538/KMT, for any fees, Including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 3 of this paper.

Page 1

390317_1.DOC